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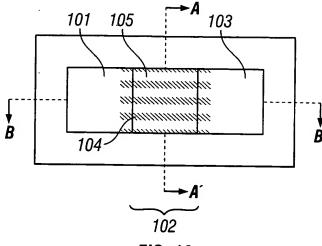


FIG. 1A

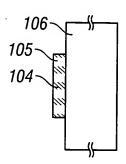


FIG. 1B

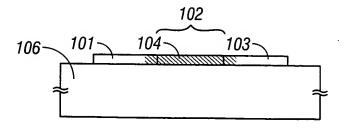


FIG. 1C

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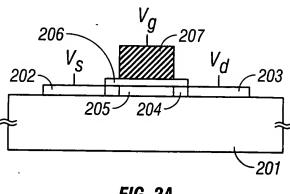


FIG. 2A (Prior Art)

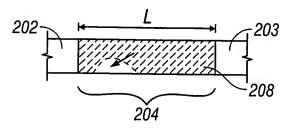


FIG. 2B (Prior Art)

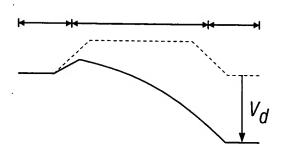
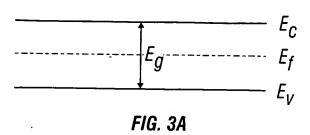


FIG. 2C (Prior Art)

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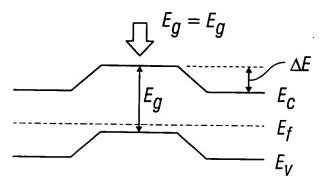


FIG. 3B

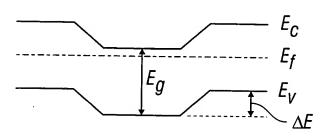


FIG. 3C

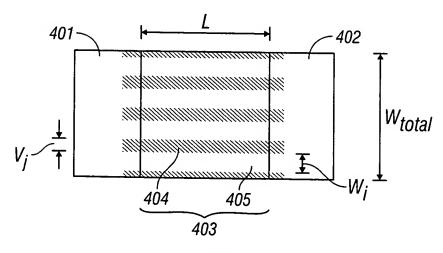


FIG. 4

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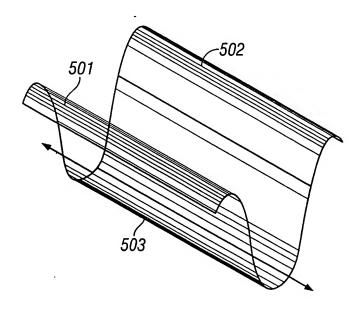


FIG. 5

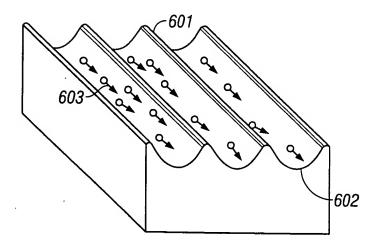


FIG. 6

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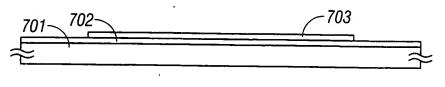


FIG. 7A

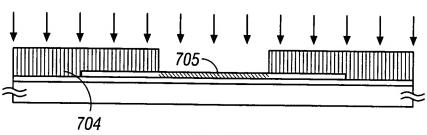


FIG. 7B

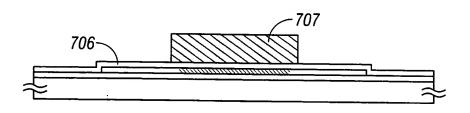


FIG. 7C

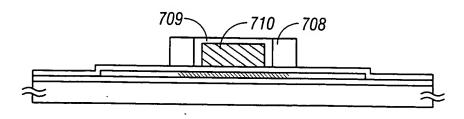
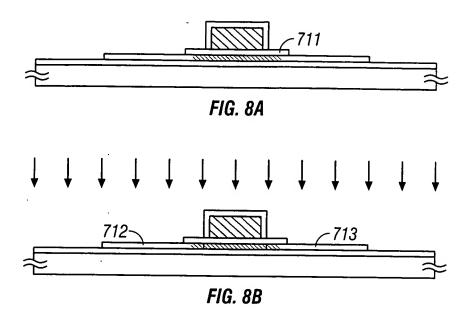
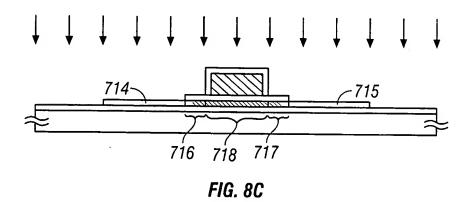


FIG. 7D

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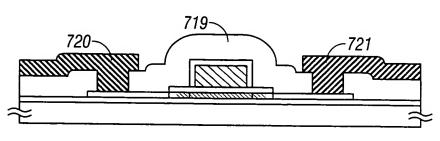


FIG. 8D

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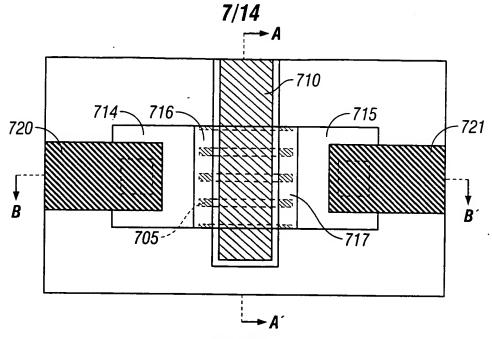


FIG. 9A

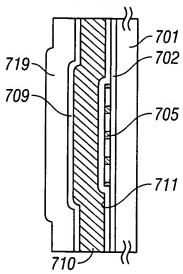


FIG. 9B

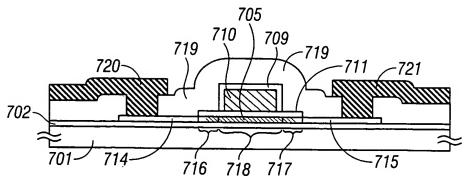


FIG. 9C

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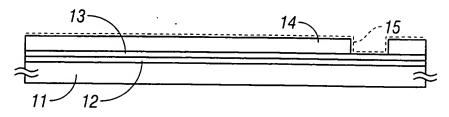


FIG. 10A

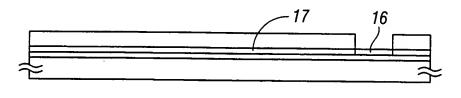
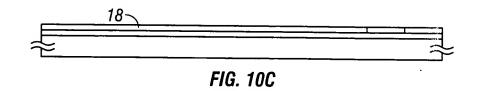


FIG. 10B



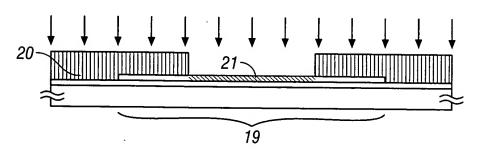


FIG. 10D

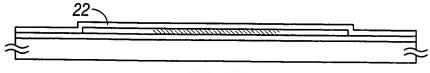
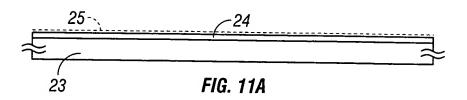
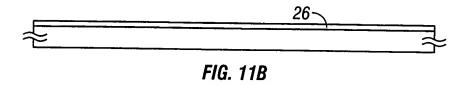
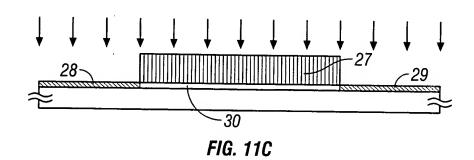


FIG. 10E

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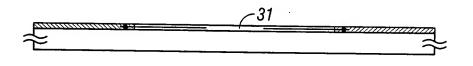


FIG. 11D



FIG. 11E

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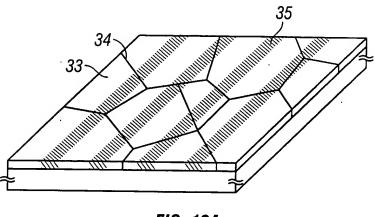
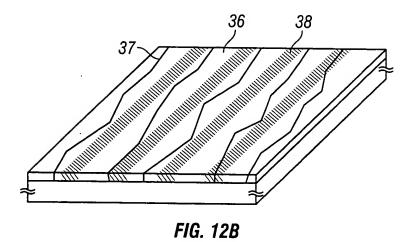
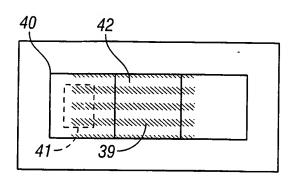


FIG. 12A



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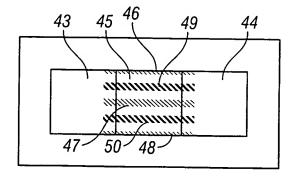


FIG. 13

FIG. 14

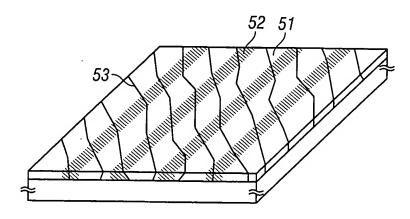


FIG. 15A

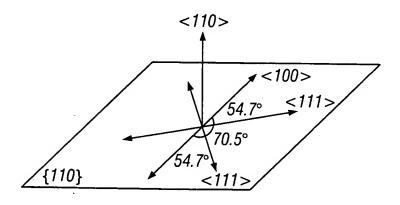
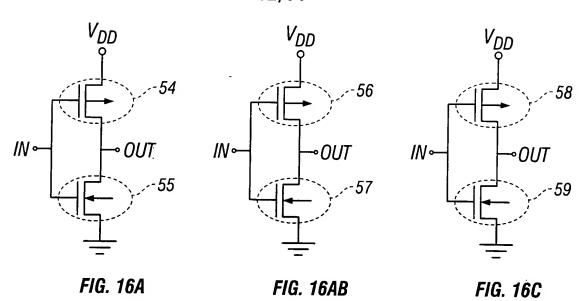


FIG. 15B

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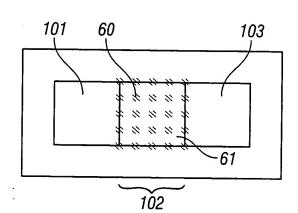


FIG. 17

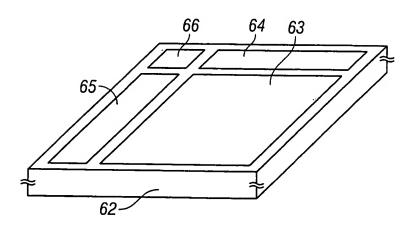


FIG. 18

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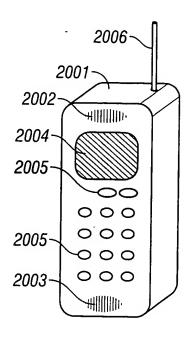


FIG. 19A

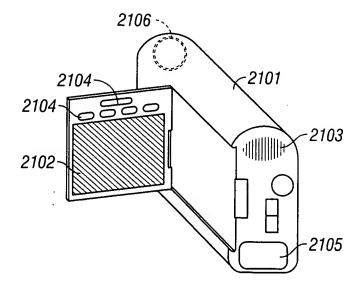


FIG. 19B

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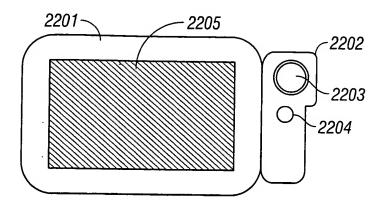


FIG. 19C

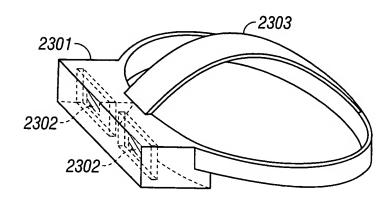


FIG. 19D

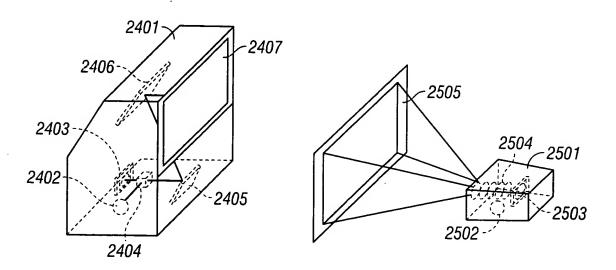


FIG. 19E

FIG. 19F